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EFS ID:

55594

Application ID:

09917842

Title of Invention:

ATOMIC LAYER DEPOSITION

APPARATUS

First Named Inventor:

Barry Chin

Domestic/Foreign Application:

Domestic Application

Filing Date:

2001-07-27

Effective Receipt Date:

2004-02-16

Submission Type:

Information Disclosure

Statement

Filing Type:

Confirmation number:

3573

Attorney Docket Number:

5017Y01

Total Fees Authorized:

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Payment Category:

Deposit Account

Deposit Account Number:

200782

Deposit Account Name:

Keith P Taboada

Access Code:

RAM Payment Status:

RAM success

RAM User ID:

EFSPROD

RAM Accounting Date:

2004-02-16

RAM Sequence Number:

29

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Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

ATOMIC LAYER DEPOSITION APPARATUS

Application Number:

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Date:

2001-07-27

First Named Applicant:

Barry L. Chin

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Confirmation Number: 3573
Attorney Docket Number: 5017Y01

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Submitted by:	Elec. Sign.	Sign. Capacity
Keith P Taboada Registered Number: 45150	/Keith P Taboada/	Attorney

Documents being submitted

Files

us-ids

APPM5017Y01-usidst.xml

us-ids.dtd

us-ids.xsl

us-fee-sheet

APPM5017Y01-usfees.xml

us-fee-sheet.xsl

us-fee-sheet.dtd



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Electronic Version v08 Stylesheet Version v08.0

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First Named Applicant:

Barry L. Chin

Attorney Docket Number: 5017Y01

Art Unit:

Examiner:

3573

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TOTAL FEE AUTHORIZED \$180

Patent fees are subject to annual revisions on or about October 1st of each year.

BASIC FILING FEE

Fee Description	Fee Code	Amount \$	Fee Paid \$
Submission Of Information Disclosure Stmt Fee.	1806	180	180

AUTHORIZED BILLING INFORMATION

The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:

Deposit account number: 200782

Access Code

Deposit name:

Moser Patterson Sheridan LLP

Deposit authorized name: Keith P Taboada

Signature:

/Keith P Taboada/

Date (YYYYMMDD):

2004-02-13



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> Title of Invention

ATOMIC LAYER DEPOSITION APPARATUS

Application Number:

09/917842

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2001-07-27

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Examiner:

Alexander Kosowski

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Fee Description	Fee Code	Amount \$	Fee Paid \$
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2004-02-13



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

ATOMIC LAYER DEPOSITION APPARATUS

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09/917842

Confirmation Number:

3573

First Named Applicant:

Barry Chin

Attorney Docket Number: 5017Y01

Art Unit:

3573

Examiner:

Alexander Kosowski

Search string:

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or 6551406 or 6511539 or 6481945 or 6478872 or 6447607 or 6306216 or 6305314 or 6270572

or 6231672 or 6200893 or 6197683 or 6183563 or 6174377 or 6139700 or 6042652 or 6015590 or 5916365 or 5879459 or 5855680 or 5835677

or 5916365 or 5879459 or 5855680 or 5835677 or 5807792 or 5796116 or 5730802 or 5711811 or 5674786 or 5503875 or 5483919 or 5480818 or 5443647 or 5441703 or 5374570 or 5338362 or 5294286 or 5281274 or 5261959 or 5225366

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US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6630030	2003-10-07	Suntola et al.	B1		
	2	6579372	2003-06-17	Park	B2 ⁻		
	3	6578287	2003-06-17	Aswad	B2		
	4	6572705	2003-06-03	Suntola et al:			
	5	6551406	2003-04-22	Kilpi			
	6	6511539 ⁻	2003-01-28	Raaijmakers			
	7	6481945	2002-11-19	Hasper et al			
	8	6478872	2002-11-12	Chae et al:			
	9	6447607 ⁻	2002-09-10	Soininen et al.			
	10	6306216	2002-10-23	Kim et al.			

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11	6305314	2001-10-23	Sneh et al
12	6270572	2001-08-07	Kim et al.
13	6231672	2001-05-15	Choi et al.
14	6200893	2001-03-13	Sneh
15	6197683	2001-03-06	Kang et al.
16	6183563	2001-02-06	Choi et al.
17	6174377	2001-01-16	Doering et al.
18	6139700	2000-10-31	Kang et al.
19	6042652	2000-03-28	Hyun et al.
20	6015590	2000-01-18	Suntola et al.
21	5916365	1999-06-29	Sherman
22	5879459	1999-03-09	Gadgil et al.
23	5855680	1999-01-05	Soininen et al.
24	5835677	1998-11-10	Li et al.
25	5807792	1998-09-15	llg et al.
26	5796116	1998-08-18	Nakata et al.
27	5730802	1998-03-24	Ishizumi et al.
28	5711811	1998-01-27	Suntola et al.
29	5674786	1997-10-07	Turner et al.
30	5503875	1996-04-02	lmai et al.
31	5483919.	1996-01-16	Yokoyama et al.
32	5480818	1996-01-02	Matsumoto et al.
33	5443647	1995-08-22	Aucoin et al.
34	5441703	1995-08-15	Jurgensen
35	5374570	1994-12-20	Nasu et al:
36	5338362	1994-08-16	Imahashi
37	5294286	1994-03-15	Nishizawa et al.
38	5281274	1994-01-25	Yoder
39	5261959	1993-11-16	Gasworth
40	5225366	1993-07-06	Yoder
41	4993357	1991-02-19	Scholz [,]
42	4975252	1990-12-04	Nishizawa et al.
43	4834831	1989-05-30	Nishizawa et al.
44	4413022	1983-11-01	Suntola et al.
45	4389973	1983-06-28	Suntola et al.
46	4058430	1977-11-15	Suntola et al.

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Note: Remarks are not for responding to an office action.

This Information Disclosure Statement is being filed in conjuction with a PAPER Information Disclosure Statement referencing Foreign patent. The necessary Fee being submitted herewith is for both Information Disclosure Statements.

Signature

Examiner Name	Date

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